

11-29-05

AF/1765  
JFW



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Record No. GI 73274329T45  
On: Nov - 28 - 05  
By: Patricia Muir  
Patricia Muir

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: Yoshihisa MATSUBARA et al.  
Serial No.: 09/840,386  
Filed: April 23, 2001  
Title: **METHOD FOR MANUFACTURING SEMICONDUCTOR  
DEVICE, AND PROCESSING SYSTEM AND  
SEMICONDUCTOR DEVICE**  
Examiner: Lan Vinh  
Group Art Unit: 1765  
Confirmation No.: 2510  
Attorney Docket No.: 100806-00199 (NEKA 18.612)

November 28, 2005

Mail Stop AF  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**NOTICE OF APPEAL**

Sir:

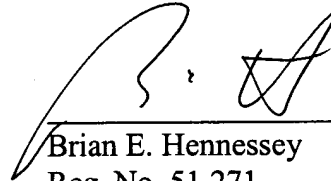
Applicants hereby appeal to the Board of Appeal from the final rejection dated June 28, 05, of non-allowed claims 1,2,13-16, and 18

1. (x) An extension of time to respond to the final rejection is requested for two (2) month(s).

2. (x) A timely response to the final rejection has been filed, as provided in 841 O.G. 1411.

Any fee due with this paper may be charged to Deposit Account 50-1290.

Respectfully submitted,



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Reg. No. 51,271

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ATTORNEY DOCKET NO.:100806-00199 NEKA 18.612

BEH:pm